



48/008  
11/9/01  
Harrison  
503.39864X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: **T. SATOH et al.**

Application No.: **09/809,181**

Filing Date: **March 16, 2001**

Title: **SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD  
THEREOF**

Art Unit: **2812**

Examiner: **D. Zarneke**

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 CFR §1.97 & §1.98**

Assistant Commissioner of Patents  
Washington, D.C. 20231

**October 29, 2001**

Sir:

In the matter of the above-identified application, applicant(s) is/are submitting herewith copies of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

The U.S. patent document listed on the attached form equivalent to Form PTO-1449 is in the English language.

To the extent that, the foreign documents listed on the attached form equivalent to Form PTO-1449, are not in the English language, the requirement of 37 CFR §1.98(a)(3) for a concise explanation of the relevance is satisfied by the abstracts attached to each of the foreign patents.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

TECHNICAL INFORMATION  
DISCLOSURE STATEMENT  
10/29/01  
11/9/01  
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Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 and please credit any excess fees to such deposit account.

Respectfully submitted,

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